



PATENT Attorney Docket No. 02887.0259

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:	)
Junji SUGAMOTO et al.	) Group Art Unit: 2891
Application No.: 10/706,090	) Examiner: Smith, Bradley
Filed: November 13, 2003	) )
For: SEMICONDUCTOR WAFER TREATMENT METHOD, SEMICONDUCTOR WAFER INSPECTION METHOD, SEMICONDUCTOR DEVICE DEVELOPMENT METHOD AND SEMICONDUCTOR WAFER TREATMENT APPARATUS	) Confirmation No.: 7292 ) ) ) ) ) ) )

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT**

In reply to the Office Action mailed August 2, 2006, the period for response to which extends through November 2, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment section of this paper.